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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT(S)**

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Inventors : Masahiko SAITO, et al.
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Examiner : Kenneth Tang



U.S. PATENT DOCUMENTS

Examiner Initial	Patent Number	Patent Date	Name	Class/ Subclass	Filing Date
KF	5,826,081	10/20/98	ZOLNOWSKY	395/673	

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class/ Subclass	Translation Yes No
KF	05-108380	04/30/93	Japan		ABS.
KF	04-367037	12/18/92	Japan		ABS.

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
KF	1. The Survey of HITACHI Technology, HITACHI HYOURON, Japan, HITACHI HYOURON CORPORATION, Jan. 1999, Vol. 81, number 1, pages 27-29.
KF	2. Office Action (Rejection Reasons Notification) issued in the Japanese Priority Application No. heisei 11-041032, 27 April 2004 & translation thereof.

EXAMINER

DATE CONSIDERED

Kenneth Tang

10/12/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.